IPR2016-01377 U.S. Patent No. 6,197,696

UNITED STATES PATENT AND TRADEMARK OFFICE

BEFORE THE PATENT TRIAL AND APPEAL BOARD

TAIWAN SEMICONDUCTOR MANUFACTURING COMPANY, LTD. and GLOBALFOUNDRIES U.S. INC., Petitioners,

v.

GODO KAISHA IP BRIDGE 1, Patent Owner.

Case No. IPR2016-01377¹ Patent Number 6,197,696

Before JUSTIN T. ARBES, MICHAEL J. FITZPATRICK, and JENNIFER MEYER CHAGNON, *Administrative Patent Judges*.

PATENT OWNER'S UPDATED LIST OF EXHIBITS

¹ GlobalFoundries U.S. Inc., who filed Petition IPR2017-00922, has been joined as

a petitioner in this proceeding.

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In accordance with 37 C.F.R. § 42.63(e), Patent Owner Godo Kaisha IP

Bridge 1 ("Patent Owner") hereby submits a current listing of Patent Owner's

exhibits.

Exhibit	Description	Previously Filed
EX2001	N. Sclater & J. Markus, McGraw-Hill Electronics	X
	Dictionary (6th ed. 1997) (excerpted)	
EX2002	R. F. Graf, Modern Dictionary of Electronics (6th ed. 1984) (excerpted)	Х
EX2003	R. F. Graf, Modern Dictionary of Electronics (7th ed.	X
	1999) (excerpted)	
EX2004	S. M. Kaplan, Wiley Electrical and Electronics Engineering Dictionary (2004) (excerpted)	Х
EX2005	October 7, 2016 Preliminary Constructions, <i>Godo</i>	X
LAZOUJ	<i>Kaisha IP Bridge 1 v. Broadcom Ltd., et al.</i> , (E.D. Tex 2:16-CV-134-JRG-RSP)	Λ
EX2006	Hans Domininghaus, Plastics for Engineers: Materials, Properties, Applications (1993) (excerpted)	X
EX2007	U. S. Patent No. 6,147,009 to Grill et al.	X
EX2008	Declaration of Seung Woo Hur	X
EX2009	Declaration of Alexander Glew, Ph.D. In Support of Patent Owner's Response Under 37 C.F. R. § 42.120	Х
EX2010	Deposition of Bruce Smith in <i>Taiwan Semiconductor</i> <i>Manufacturing Co., v. Godo Kaisha IP Bridge</i> <i>1</i> (P.T.A.B. IPR2016-01376) taken on March 23, 2017	X
EX2011	Redline Comparing Grill (EX1005) with Grill's Provisional (EX1017) Application	X
EX2012	Japanese Patent Application 10-079371 to Aoi as Submitted in European Patent Application No. 99 105 946.0 with accompanying translation	X
EX2013	Declaration of Takeo Ohashi, Ph.D. In Support of Patent Owner's Response Under 37 C.F. R. § 42.120	X
EX2014	Influence of reactor wall conditions on etch processes in inductively coupled fluorocarbon plasmas by M.	X

List of Exhibits

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	Schaepkens, et al., J. Vac. Sci. Tech. A 16(4), Jul/Aug 1998	
EX2015	Handbook of VLSI Microlithography, Second Edition, Principles, Technology, and Applications, edited by John N. Helbert, Noyes Publications, William Andrew Publishing, LLC, 2001	х
EX2016	Silicon VLSI Technology Fundamentals, Practice and Modeling, by James D. Plummer, et al., Prentice Hall, 2000	Х
EX2017	<i>Microlithography: Science and Technology</i> , by James R. Sheats and Bruce W. Smith, Marcel Dekker, Inc., 1998	Х
EX2018	<i>Microlithography: Science and Technology</i> , 2 nd ed., by James R. Sheats and Bruce W. Smith, CRC Press, 2007	Х
EX2019	<i>Microlithography: Science and Technology</i> , 2 nd ed., by James R. Sheats and Bruce W. Smith, CRC Press, 2007	Х
EX2020	Silicon Processing for The VLSI Era Vol. 2 Process Integration by Stanley Wolf and R.N. Tauber, Lattice Press, 1986	Х
EX2021	Kenkyusha's New Japanese-English Dictionary, 4 th ed., 35 th Impression, published by Kenkyusha Ltd., 1997	X
EX2022	Declaration of Jordan M. Rossen In Support of Patent Owner's Response Under 37 C.F. R. § 42.120	Х
EX2023	Declaration of Susann Brailey and Exhibit A regarding Influence of reactor wall conditions on etch processes in inductively coupled fluorocarbon plasmas by M. Schaepkens, et al., J. Vac. Sci. Tech. A 16(4), Jul/Aug 1998	Served only.
EX2024	Affidavit of Pamela Stansbury regarding <i>Influence of</i> <i>reactor wall conditions on etch processes in inductively</i> <i>coupled fluorocarbon plasmas</i> by M. Schaepkens, et al., J. Vac. Sci. Tech. A 16(4), Jul/Aug 1998	Served only.
EX2025	Influence of reactor wall conditions on etch processes in inductively coupled fluorocarbon plasmas by M. Schaepkens, et al., J. Vac. Sci. Tech. A 16(4), Jul/Aug 1998	Served only.
EX2026	Library of Congress Certification of <i>Handbook of VLSI</i> <i>Microlithography, Second Edition, Principles,</i> <i>Technology, and Applications</i> , edited by John N.	Served only.

Helbert, Noyes Publications, William Andrew	
	Х
Applications, edited by William B. Glendinning and	
John N. Helbert, Noyes Publications, William Andrew	
Publishing, LLC, 1991 (excerpted)	
Library of Congress Certification of Silicon VLSI	Served
Technology Fundamentals, Practice and Modeling, by	only.
James D. Plummer, et al., Prentice Hall, 2000	
(excerpted)	
Affidavit of Pamela Stansbury regarding Silicon VLSI	Served
	only.
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2000 (excerpted)	2
Library of Congress Certification of <i>Microlithography:</i>	Served
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Silicon Processing for The VLSI Era Vol. 1 Process	Served
<i>Technology</i> by Stanley Wolf and R.N. Tauber, Lattice	only.
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Press, 1986 (excerpted)	•
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Press, 1986 (excerpted)	•
	Publishing, LLC, 2001 (excerpted)Library of Congress Certification of Handbook of VLSIMicrolithography, Principles, Technology, andApplications, edited by William B. Glendinning andJohn N. Helbert, Noyes Publications, William AndrewPublishing, LLC, 1991 (excerpted)Library of Congress Certification of Silicon VLSITechnology Fundamentals, Practice and Modeling, byJames D. Plummer, et al., Prentice Hall, 2000(excerpted)Affidavit of Pamela Stansbury regarding Silicon VLSITechnology Fundamentals, Practice and Modeling, byJames D. Plummer, et al., Prentice Hall, 2000Silicon VLSI Technology Fundamentals, Practice andModeling, by James D. Plummer, et al., Prentice Hall, 2000Silicon VLSI Technology Fundamentals, Practice andModeling, by James D. Plummer, et al., Prentice Hall, 2000Silicon VLSI Technology, by James R. Sheats and BruceW. Smith, Marcel Dekker, Inc., 1998 (excerpted)Library of Congress Certification of Microlithography:Science and Technology, 2 nd ed., by Kazuaki Suzuki andBruce W. Smith, CRC Press, 2007 (Chapter 12)(excerpted) (Smith Deposition Exhibit 3)Library of Congress Certification of Microlithography:Science and Technology, 2 nd ed., by Kazuaki Suzuki andBruce W. Smith, CRC Press, 2007 (Chapter 11)(excerpted) (Smith Deposition Exhibit 3)Library of Congress Certification of Microlithography:Science and Technology, 2 nd ed., by Kazuaki Suzuki andBruce W. Smith, CRC Press, 2007 (Chapter 11)(excerpted) (Smith Deposition Exhibit 9)Affidav

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EX2038	U.S. Pat. No. 6,808,647	Served
		only.
EX2039	Declaration of Jordan M. Rossen	Served
		only.
EX2040	Transcript of the Deposition of Dr. B. Smith	X
	(August 2, 2017)	
EX2041	Patent Owner's Demonstrative Slides	

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